



P/2850-79

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Takeshi Ootsuka

Date: October 2, 2003

Serial No.: 10/613,574

Group Art Unit:

Filed: July 9, 2003

Examiner: N/A

For: ELECTRODE-BUILT-IN SUSCEPTOR

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION

Sir:

On August 4, 2003, an Information Disclosure Statement and corresponding Form 1449 was submitted in connection with the instant application.

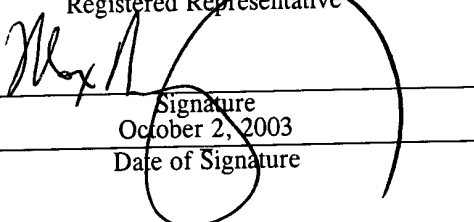
The Form 1449 inadvertently contained a clerical error in omitting the listing of JP 2001-308165 in the Foreign Patent Documents. Although all documents were included in the original submission, an additional copy of JP 2001-308165 is included herewith for the convenience of the Examiner.

In the listing of Foreign Patent Documents and Other Documents, the Japanese Patent Documents No. JP-1-0189696 should be changed to JP-10-189696 and No. 2002-124296 should be changed to 2003-124296.

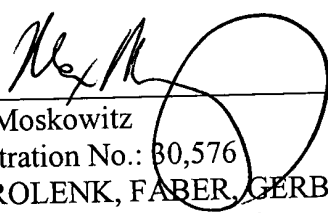
A corrected Form 1449 is hereby submitted.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on October 2, 2003  
Max Moskowitz

Name of applicant, assignee or  
Registered Representative

  
Signature  
October 2, 2003  
Date of Signature

Respectfully submitted,

  
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|----------------------------------------------------------------------|--|---------------------------|--|-------------------------|--|
| <b>APPLICANT'S ART CITATION</b><br>(Use several sheets if necessary) |  | Application 10/613,574    |  | OFGS File No. P/2850-79 |  |
|                                                                      |  | Applicant Takeshi OOTSUKA |  |                         |  |
|                                                                      |  | Filing Date July 9, 2003  |  | Group Art Unit          |  |

OCT 16 2003  
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| U.S. PATENT DOCUMENTS |                 |              |                    |       |           |                            |
|-----------------------|-----------------|--------------|--------------------|-------|-----------|----------------------------|
| Examiner Initial      | Document Number | Date MM-YYYY | Name               | Class | Sub-class | Filing Date If Appropriate |
|                       | US-2003/0089687 | 05-2003      | Maki               |       |           |                            |
|                       | US-2002/0006678 | 01-2002      | Inazumachi, et al. |       |           |                            |
|                       | US-5,688,331    | 11-1997      | Aruga, et al.      |       |           |                            |
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|--------------------------|-----------------|--------------|---------|-------|-----------|-------------|----|
|                          | Document Number | Date MM-YYYY | Country | Class | Sub-class | Translation |    |
|                          |                 |              |         |       |           | Yes         | No |
|                          | 2001-287982     | 10-2001      | Japan   |       |           |             | X  |
|                          | 2003-152064     | 05-2003      | Japan   |       |           |             | X  |
|                          | 7-153706        | 06-1995      | Japan   |       |           |             | X  |
|                          | JP-4-3001136    | 10-1992      | Japan   |       |           |             | X  |
|                          | JP-6-151044     | 05-1994      | Japan   |       |           |             | X  |
|                          | JP-6-151332     | 05-1994      | Japan   |       |           |             | X  |
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|                          | JP-2001-085505  | 03-2001      | Japan   |       |           |             |    |
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| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) |                                                                                    |
|------------------------------------------------------------------------|------------------------------------------------------------------------------------|
|                                                                        | English translation of Abstract for Japanese Patent Application No. JP-4-3001136   |
|                                                                        | English translation of Abstract for Japanese Patent Application No. JP-6-151044    |
|                                                                        | English translation of Abstract for Japanese Patent Application No. JP-6-151332    |
|                                                                        | English translation of Abstract for Japanese Patent Application No. JP-10-189696   |
|                                                                        | English translation of Abstract for Japanese Patent Application No. 2003-124296    |
|                                                                        | English translation of Abstract for Japanese Patent Application No. JP-2001-085505 |

|          |                 |
|----------|-----------------|
| Examiner | Date Considered |
|----------|-----------------|

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.